



EPJ

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

TSUDA et al

Atty. Ref.: 1114-134; Confirmation No. 1852

Appl. No. 09/406,684

TC/A.U. 2871

Filed: September 27, 1999

Examiner: A. Schechter

For: METHOD OF MAKING LCD WITH ASPERITIES IN INSULATION LAYER UNDER
REFLECTIVE ELECTRODE

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May 5, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO OFFICE ACTION

This is responsive to the Official Action dated April 20, 2005.